



*LAW*

PATENT APPLICATION

IN THE U.S. PATENT AND TRADEMARK OFFICE

September 2, 2005

Applicant(s): Yuji AKIMOTO et al

For: METHOD FOR MANUFACTURING HIGHLY-CRYSTALLIZED  
DOUBLE OXIDE POWDER

Serial No.: 10/611 720

Group: 1755

Confirmation No.: 6093

Filed: July 1, 2003

Examiner: Unknown

Atty. Docket No.: Komatsu Case 287

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

**INFORMATION DISCLOSURE STATEMENT**

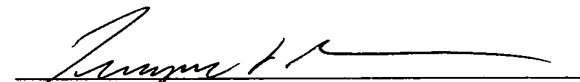
Sir:

In compliance with the provisions of Rules 1.97(e)(1) and 1.98, enclosed herewith is a copy of a Chinese Office Action, Form PTO-1449 and the reference cited thereon.

The undersigned hereby certifies under Rule 1.97(e)(1) that each item of information contained in this Information Disclosure Statement was cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to filing of this Information Disclosure Statement.

Further consideration is respectfully solicited.

Respectfully submitted,

  
Terryence F. Chapman

TFC/jp

FLYNN, THIEL, BOUTELL  
& TANIS, P.C.  
2026 Rambling Road  
Kalamazoo, MI 49008-1631  
Phone: (269) 381-1156  
Fax: (269) 381-5465

Dale H. Thiel  
David G. Boutell  
Ronald J. Tanis  
Terryence F. Chapman  
Mark L. Maki  
Liane L. Churney  
Brian R. Tumm  
Steven R. Thiel  
Donald J. Wallace  
Kevin L. Pontius  
Sidney B. Williams, Jr.

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Reg. No. 37 512  
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Encl: Copy of Chinese Office Action dated June 10, 2005  
Form PTO-1449 and cited reference  
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Applicant(s): Yuji AKIMOTO et al  
Title : METHOD FOR MANUFACTURING HIGHLY-CRYSTALLIZED  
DOUBLE OXIDE POWDER

Serial No. : 10/611 720                      Group: 1755  
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Filed : July 1, 2003                      Examiner: Unknown  
International Application No.: N/A  
International Filing Date : N/A  
Atty. Docket No.: Komatsu Case 287

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**FIRST CLASS MAILING CERTIFICATE**

Sir:

I hereby certify that this correspondence is being deposited with the United States Postal Service under 37 CFR 1.8 as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on September 2, 2005.

  
Terryence F. Chapman

TFC/jp

FLYNN, THIEL, BOUTELL	Dale H. Thiel	Reg. No. 24 323
& TANIS, P.C.	David G. Boutell	Reg. No. 25 072
2026 Rambling Road	Ronald J. Tanis	Reg. No. 22 724
Kalamazoo, MI 49008-1631	Terryence F. Chapman	Reg. No. 32 549
Phone: (269) 381-1156	Mark L. Maki	Reg. No. 36 589
Fax: (269) 381-5465	Liane L. Churney	Reg. No. 40 694
	Brian R. Tumm	Reg. No. 36 328
	Steven R. Thiel	Reg. No. 53 685
	Donald J. Wallace	Reg. No. 43 977
	Kevin L. Pontius	Reg. No. 37 512
	Sidney B. Williams, Jr.	Reg. No. 24 949

Correspondence: Information Disclosure Statement dated  
September 2, 2005, and all enclosures listed  
thereon

190.05/05

INFORMATION DISCLOSURE CITATION	Applicant: Yuji AKIMOTO et al
	Ser.No.: 10/611 720      Filed: July 1, 2003
	Conf. No.: 6093      Atty. Docket No.: Komatsu Case 287
	Group: 1755

## U.S. PATENT DOCUMENTS

Examiner Initials*	Cite No.	Document Number - Kind Code	Publication Date MM-DD-YYYY	Name of Patentee or Applicant
	AA			
	AB			
	AC			
	AD			
	AE			
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	AI			
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	AK			

## FOREIGN PATENT DOCUMENTS

Examiner Initials*	Cite No.	Country Code - Document Number - Kind Code	Publication Date MM-DD-YYYY	Name of Patentee or Applicant	Trans.
	AL				
	AM				
	AN				
	AO				
	AP				

## NON PATENT LITERATURE DOCUMENTS

Examiner Initials*	Cite No.	(Include Author, Title, Date, Pages, Etc.)
	AQ	Shuwang, Y., et al., "Study on Ionic Sieve of Titanium Oxide and Lithium Recovery from Brines", <i>Ion Exchange and Absorption</i> , Vol. 8, No. 3, 1992, pages 222-228
	AR	
EXAMINER SIGNATURE		DATE CONSIDERED

\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.